

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: To Be Assigned

Examiner: To Be Assigned

In re CONTINUATION PATENT APPLICATION of

Applicant(s) : Minoru WATANABE

Appln. No. : To Be Assigned

Filed : Herewith

For : METHOD AND APPARATUS FOR
FORMING RESIST PATTERN

Atty. Dkt. : MAE 223 C1

INFORMATION
DISCLOSURE
STATEMENT

11002 U.S. PTO
10/025783

12/26/01

Commissioner for Patents
Washington, D.C. 20231

Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(b)(1).

The Examiner is respectfully requested to consult related copending application serial number 09/443,500, filed on November 19, 1999, for which priority under 35 U.S.C. §120 has been relied upon, for copies of the four (4) documents listed on the attached PTO-1449 form, which have been previously submitted therein (37 C.F.R. §1.98(d)).

Since this Information Disclosure Statement is being filed with the application, no certification or fee is required, and the requirements of 37 C.F.R. §§1.97 and 1.98 are deemed to be fully met as to the document submitted. Consideration of the previously submitted documents is respectfully requested.

Respectfully submitted,

December 26, 2001

Date

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